

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

APPLN. OF: TOUNAI

FILED: March 31, 2004

FOR: METHOD OF TESTING MASK PATTERN AND PROGRAM
FOR DOING THE SAME

DOCKET: NEC A433

MAIL STOP PATENT APPLICATION
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

INFORMATION DISCLOSURE STATEMENT

Dear Sir:

In connection with the above-entitled matter, Applicant hereby attaches U.S. Patent Office Form PTO-1449, including copies of the references listed therein, which were considered prior to the initial filing, and are discussed in the specification. The claims in the present application are believed to be patentably distinguished over these references.

This information disclosure statement is being made pursuant to the duty of disclosure imposed by law and formulated in 37 CFR 1.56(A). No representation is made that the information thus disclosed in fact constitutes prior art or that it is the closest prior art, inasmuch as 37 CFR 1.56(A) relies on a materiality concept which depends on subjectivity.

In the event there are any fee deficiencies or additional fees are payable, please charge them (or credit any overpayment) to our Deposit Account No. 08-1391.

Respectfully submitted,



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INFORMATION DISCLOSURE CITATION <i>(Use several sheets if necessary)</i>	Docket Number (Optional)	Application Number
	NEC A433	
	Applicant(s)	TOUNAI
Filing Date	Group Art Unit	
March 31, 2004		

U.S. PATENT DOCUMENTS

FOREIGN PATENT DOCUMENTS

REF	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	Translation	
						YES	NO
	2000-214577	04.08.2000	JAPAN (w/Abstract)	G03F	1/08		✓
	11-338904	10.12.1999	JAPAN (w/Abstract)	G06F	17/50		✓
	11-096200	09.04.1999	JAPAN (w/Abstract)	G06F	17/50		✓
	2000-294650	20.10.2000	JAPAN (w/Abstract)	H01L	21/82		✓

OTHER DOCUMENTS (*Including Author, Title, Date, Pertinent Pages, Etc.*)

EXAMINER _____ **DATE CONSIDERED** _____

EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP Section 609; Draw line through citation if not in conformance and no considered. Include copy of this form with next communication to applicant.